

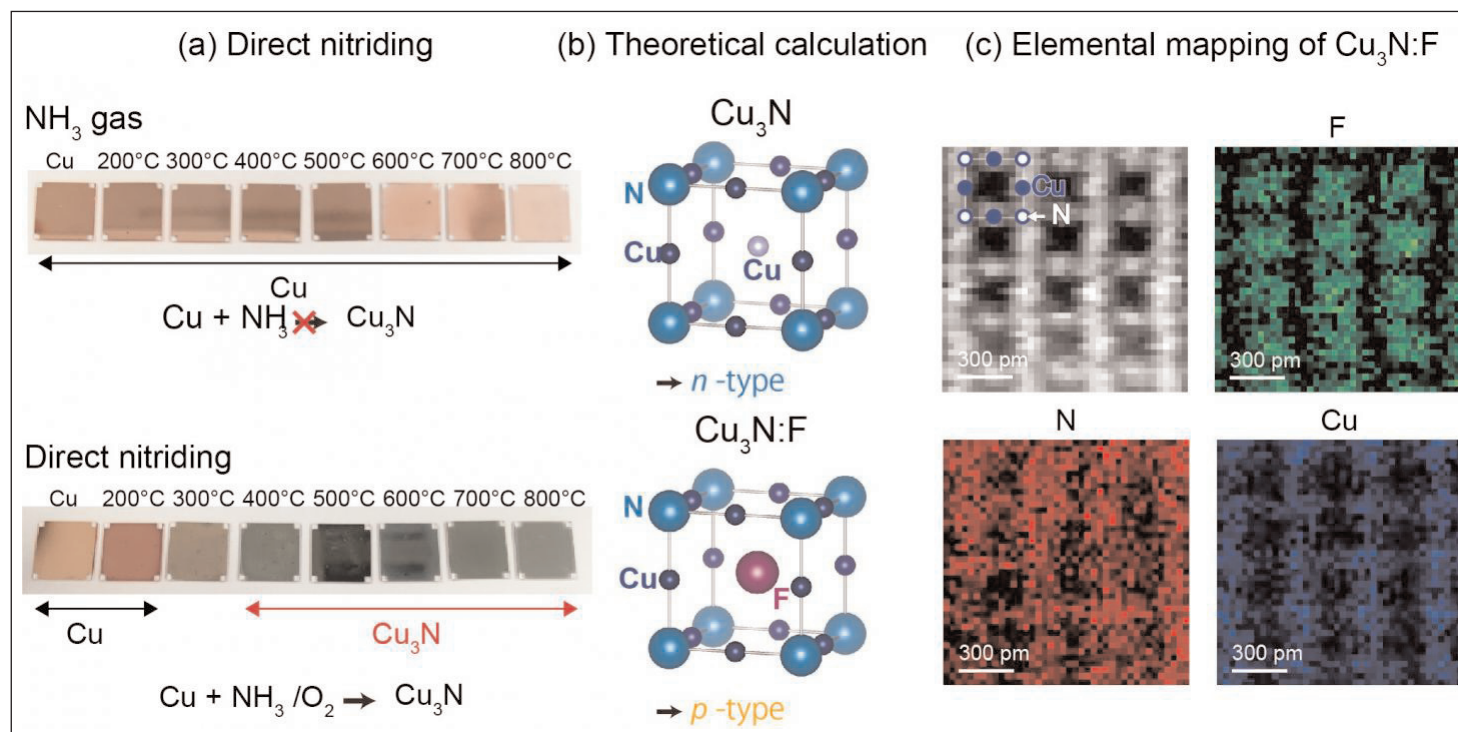
# Tokyo Institute of Technology develops n- and p-type copper nitride semiconductor for environmentally friendly thin-film photovoltaics

**Gaseous direct nitriding for uniform and large-area deposition yields a non-toxic, abundant alternative to CdTe and CIGS.**

**B**y using a unique nitriding technique applicable for mass production and a computational search for appropriate doping elements (as well as atomically resolved microscopy and electronic structure analysis using synchrotron radiation), Tokyo Institute of Technology has shown that copper nitride ( $\text{Cu}_3\text{N}$ ) acts as an n-type semiconductor, with p-type conduction provided by fluorine doping (Kosuke Matsuzaki et al,

'High-Mobility p-Type and n-Type Copper Nitride Semiconductors by Direct Nitriding Synthesis and In Silico Doping Design'). These n-type and p-type copper nitride semiconductors could potentially replace the conventional toxic or rare materials in photovoltaic cells, it is reckoned.

Compared to market-dominating silicon solar panels, thin-film photovoltaics have equivalent efficiency and



**(a) Copper and copper nitride. (b) Theoretical calculation for p-type and n-type copper nitride. (c) Direct observation of fluorine position in fluorine-doped copper nitride. (a) Thin-film copper plates before and after reacting with ammonia and oxygen. Copper metal has been transformed to copper nitride. (b) Copper insertion for n-type semiconductor and fluorine insertion for p-type semiconductor. (c) Nitrogen plotted in red, fluorine in green, and copper in blue. Fluorine is located at the open space of the crystal, as predicted by theoretical calculation.**

can cut the cost of materials. The technology allows low-cost and scalable manufacturing routes compared to crystalline silicon technology, even though toxic and rare materials are used in commercialized thin-film solar cells. Tokyo Institute of Technology aims to find a new candidate material for producing cleaner, cheaper thin-film photovoltaics.

The team has focused on a simple binary compound, copper nitride, composed of environmentally friendly elements. However, growing a nitride crystal in a high-quality form is challenging, as history shows from the development of gallium nitride (GaN) blue LEDs. Matsuzaki and his coworkers have overcome the difficulty by introducing a novel catalytic reaction route (gaseous direct nitriding) using ammonia and oxidant gas, applicable to uniform and large-area deposition. This compound — see the photograph in figure (a) — is an n-type conductor with excess electrons. On the other hand, by inserting the element fluorine in the open space of the crystal, this n-type compound was transformed into p-type, as predicted by density func-

tional theory calculations and directly proven by atomically resolved microscopy in figures (b) and (c), respectively.

All existing thin-film photovoltaics require a p-type or n-type partner in their makeup of a sandwich structure, requiring great effort to find the best combination. The p-type and n-type conduction in the same material developed by Matsuzaki and his coworkers are beneficial for designing a highly efficient solar cell structure without such efforts. The material is also non-toxic, abundant and hence potentially cheap — a suitable replacement for cadmium telluride (CdTe) and copper indium gallium diselenide (CIGS) thin-film solar cells. Tokyo Institute of Technology reckons that, with the development of these p-type and n-type semiconductors in a scalable forming technique using simple, safe and abundant elements, the positive qualities will help to bring thin-film photovoltaics to greater prominence. ■

<http://dx.doi.org/10.1002/adma.201801968>  
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